


<b>Search Notes</b>  	<b>Application/Control No.</b>  10760276	<b>Applicant(s)/Patent Under Reexamination</b>  KIM ET AL.
	<b>Examiner</b>  JANNELLE M LEBRON	<b>Art Unit</b>  2861

SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES		
Search Notes	Date	Examiner
Updated Search	4/25/2008	JML
Consulted Lamson Nguyen regarding allowability of claims	4/25/2008	JML

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner